



Ultra-light pixellated systems

J. Baudot, for the IPHC group
& the PLUME collaboration
baudot@in2p3.fr

Mont Sainte Odile, 2011 September 8

- x Motivations
- x The PLUME collaboration
- x PLUME-2010
- x PLUME-2011
- x Sensor embedding
- x Summary

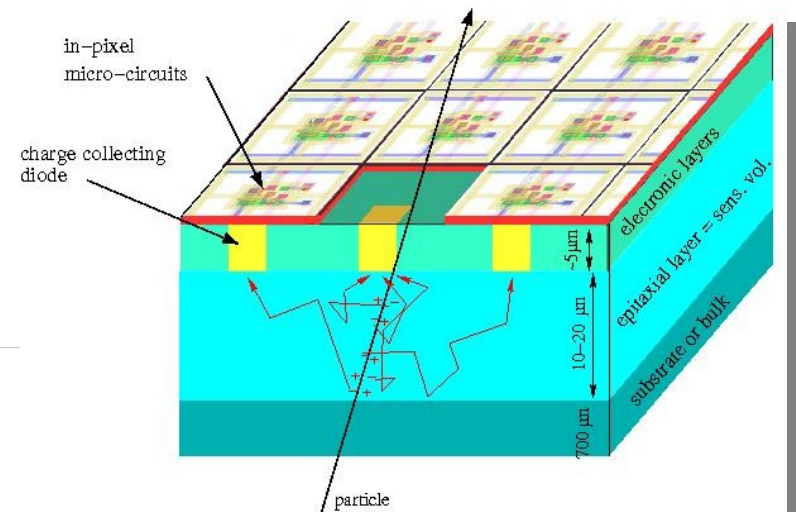
Motivations

CMOS pixel sensors

- ✗ Potentially extremely thin $\sim 25\ \mu\text{m}$
 $\sim 0.027\ \% X_0$

Questions

- ✗ How much can CMOS pixel sensors be thinned down for integration?
- ✗ Can we provide support structures & services which are not "much more thick" than the sensors?
- ✗ Any new ideas opened by such thin sensors?
- ✗ How do we benefit from industry rapid technology advances?
- ✗ Do we have the necessary skills/equipments in our laboratories?
- ✗ Do integration studies bring some feedback to the design of the sensors themselves?



The PLUME R&D

- ✗ "classical" approach
- ✗ double-sided ladders
- ✗ design ILC oriented



Sensor embedding

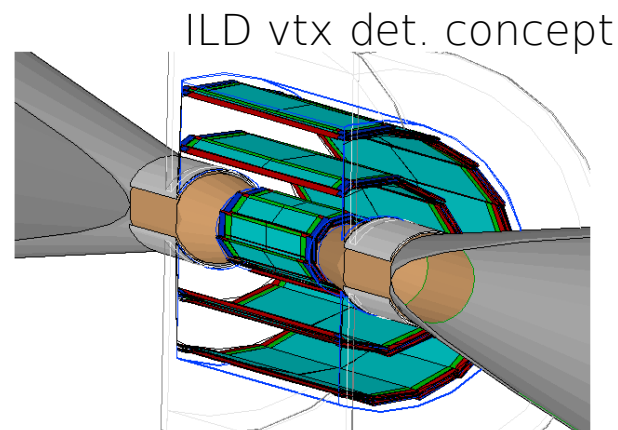
- ✗ Exploratory approach
- ✗ Exploit monolithic aspect of sensors
- ✗ R&D partly supported by FP7 Hadron-Physics2-ULIS1



The PLUME collaboration

● ILC-oriented

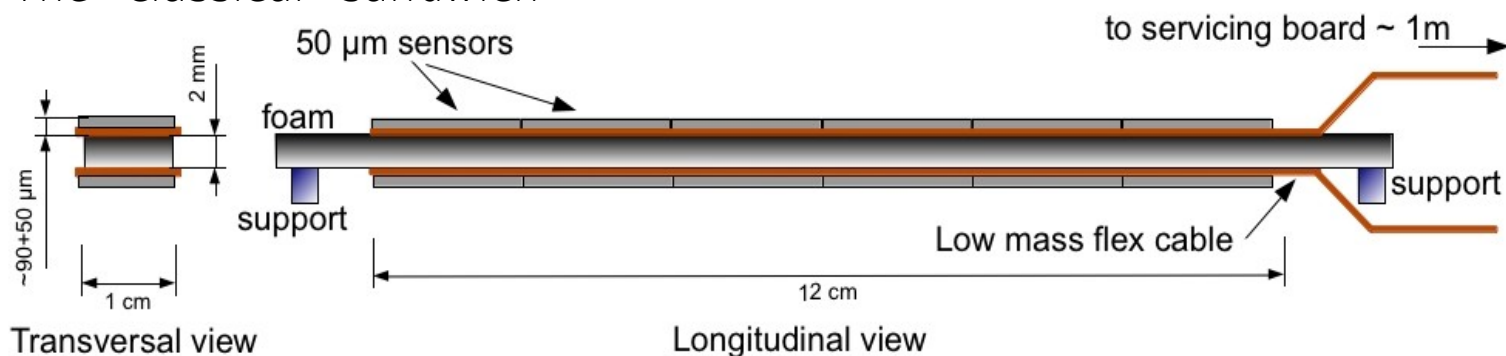
- x Double-sided ladders
- x Air cooled
- x Power pulsed @ $T=200\text{ms}$
- x 125 mm long
- x Material budget goal $\sim 0.3\% X_0$
- x Results expected for mid-2012



● Double-sided ladders benefits

- x Redundancy
- x Alignment: faster and/or more robust
- x Track finding boosted by mini-vectors
- x Note: material budget increase \sim few $0.1\% X_0$ between single- and double-sided options

The “classical” sandwich





The PLUME collaboration



- Mechanical design stiffener, supports
- Stability measurements
- Modules mounting on ladders



- Simulations (FEA)
- Ladder mock-up & thermal measurement
- Power pulsing tests



- Sensors mounting on modules
- Electrical tests
- Readout & DAQ
- Cooling system
- Test beam infrastructure & analysis



- Low-mass cable design & test
- Test beam analysis

Synergy with

- ✗ IKF – Frankfurt, CBM group
- ✗ LBNL – Berkeley, STAR-HFT group



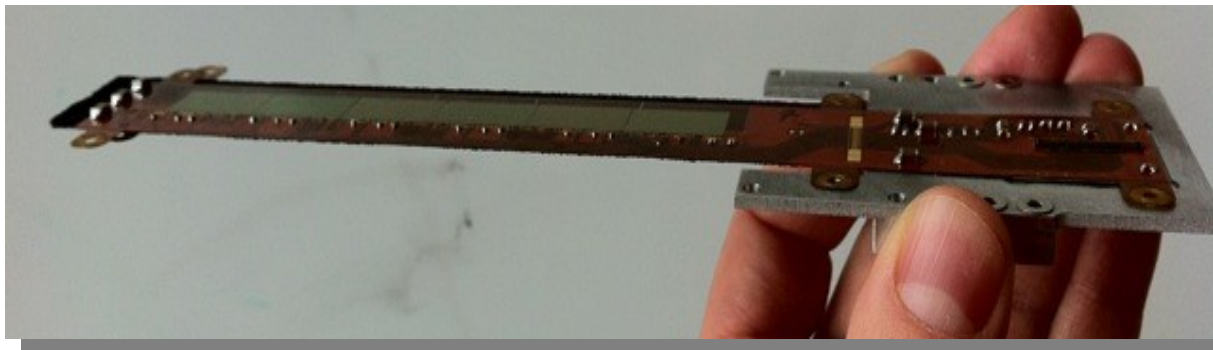
PLUME-2010 design

● Goals

- x Electrical functionality with 6 MIMOSA 26 (see M.Winter's talk)
- x Address the full fabrication, assembly & test chains
- x Note: MIMOSA 26 not designed for power pulsing

● Key features

- x 6x MIMOSA 26 thinned down to $50\text{ }\mu\text{m}$
- x Low mass cable = $140\text{ }\mu\text{m}$ thick with $2\times 20\text{ }\mu\text{m}$ copper
- x Spacer = SiC foam at 8% density
- x 1 ladder = 8M pixels, 10g, 0.6 % X_0 (cross section)



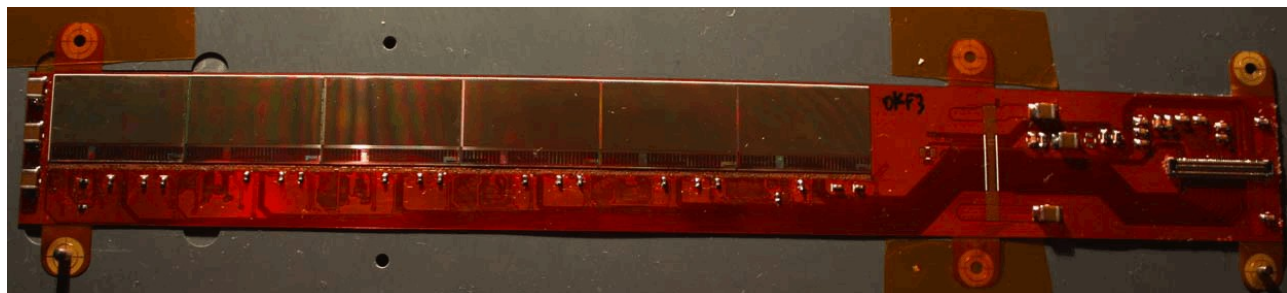


PLUME-2010 design

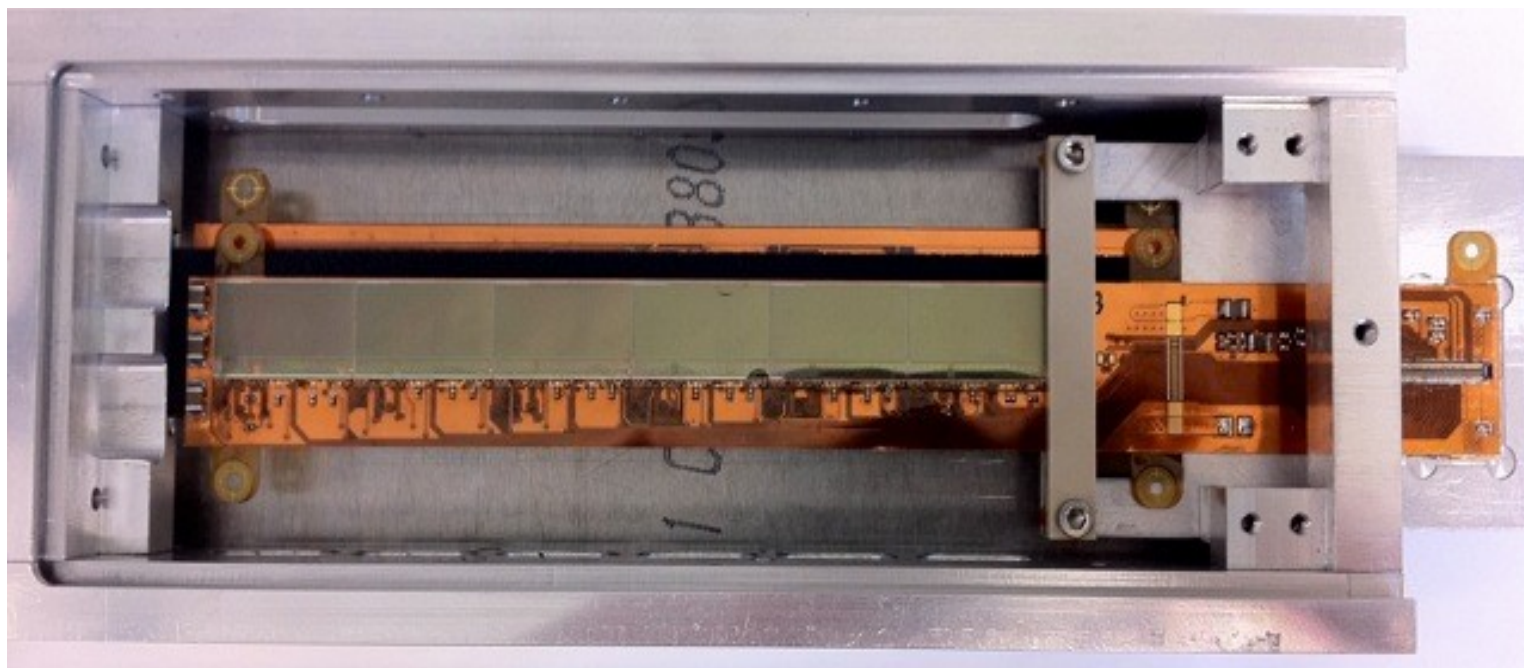
bare low mass cable



module with 6 sensors



complete ladder
(2 modules)

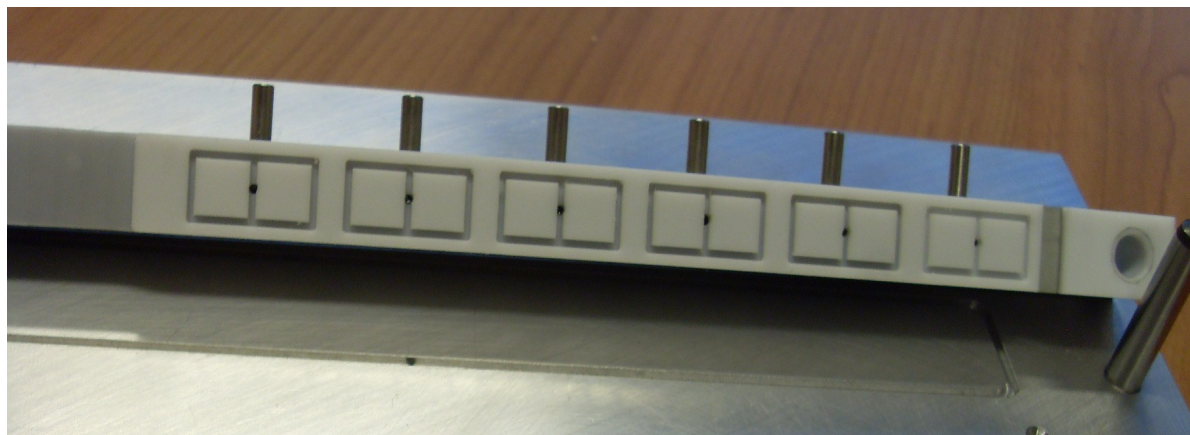
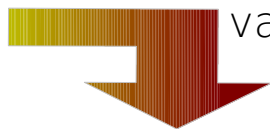




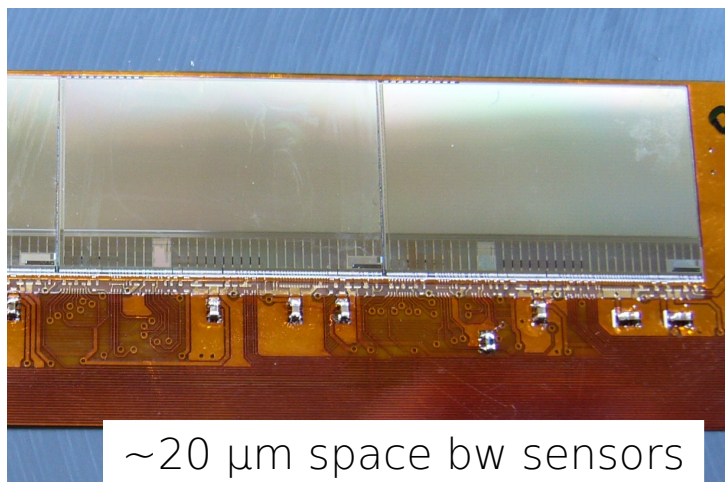
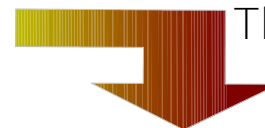
PLUME-2010 module assembly

MIMOSA 26
50 μm thick

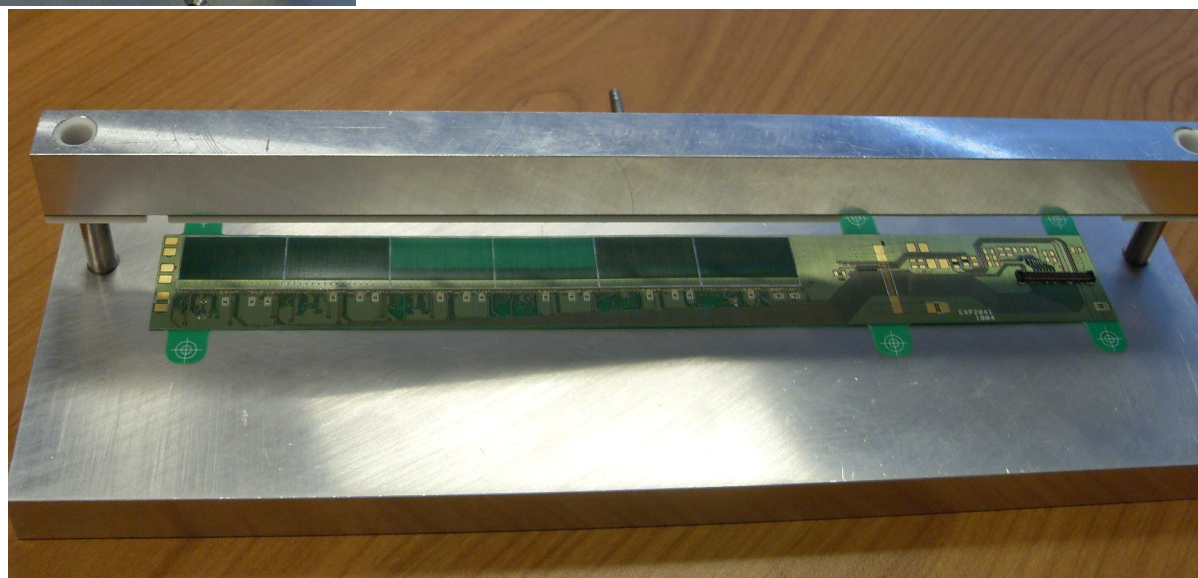
x6, manual positioning,
vacuum fixed



Controlled glue dispensing
small pressure while curing
Then wire bonding

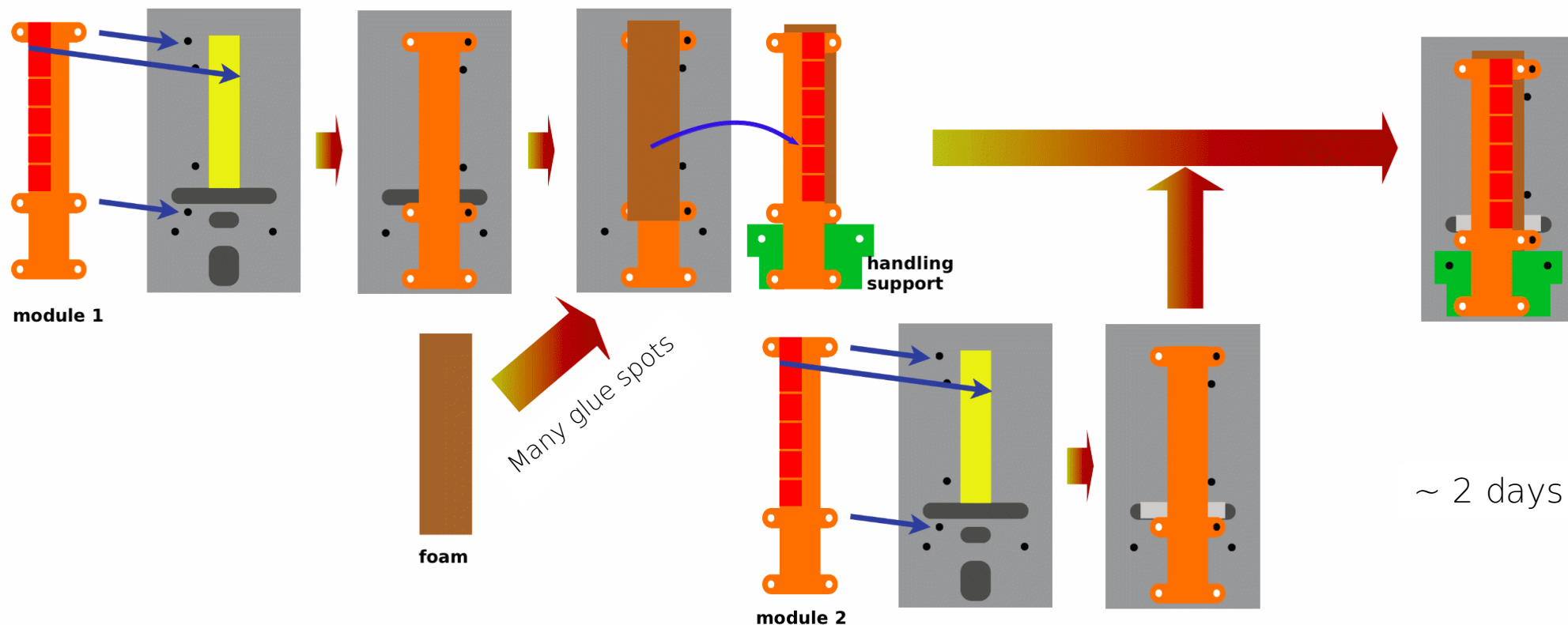


~20 μm space bw sensors





PLUME-2010 ladder assembly



Modules

- x ~30 low mass cables produced (all copper)
- x 5 equipped with 6 MIMOSA26
 - ➔ All electrically functional
 - ➔ 3 with 1 or 2 non-functional sensors

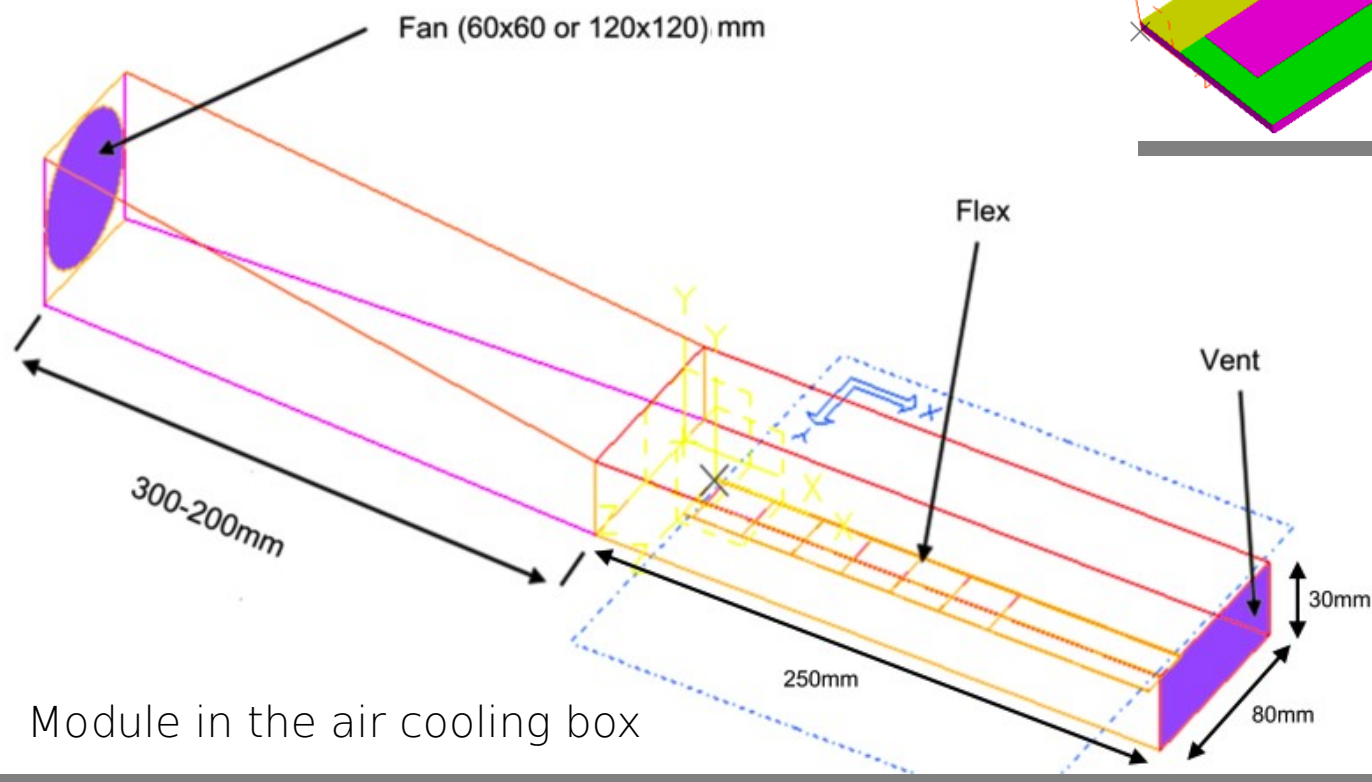
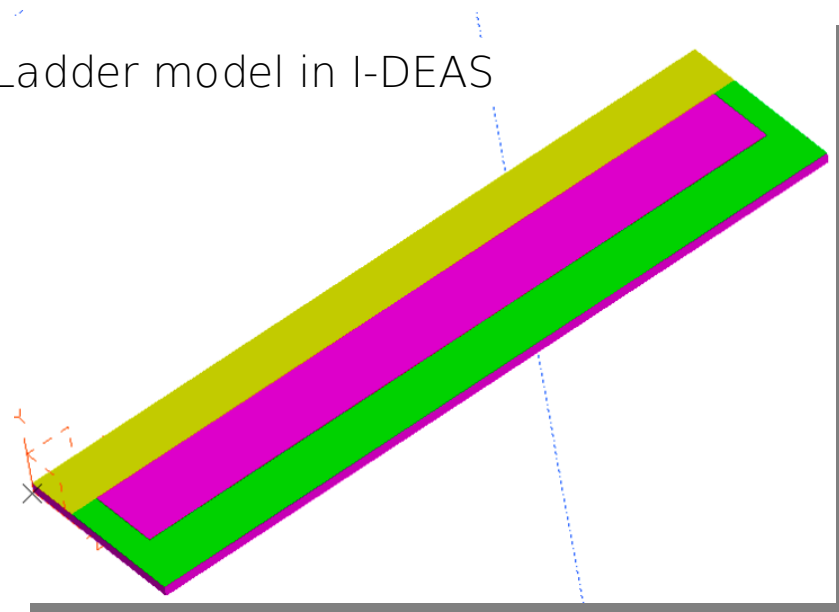
Ladders

- x 3 assembled
 - ➔ 1 with dummy sensors
 - ➔ 1 electrically functional
 - ➔ 1 still curing



PLUME-2010 simulations

Ladder model in I-DEAS

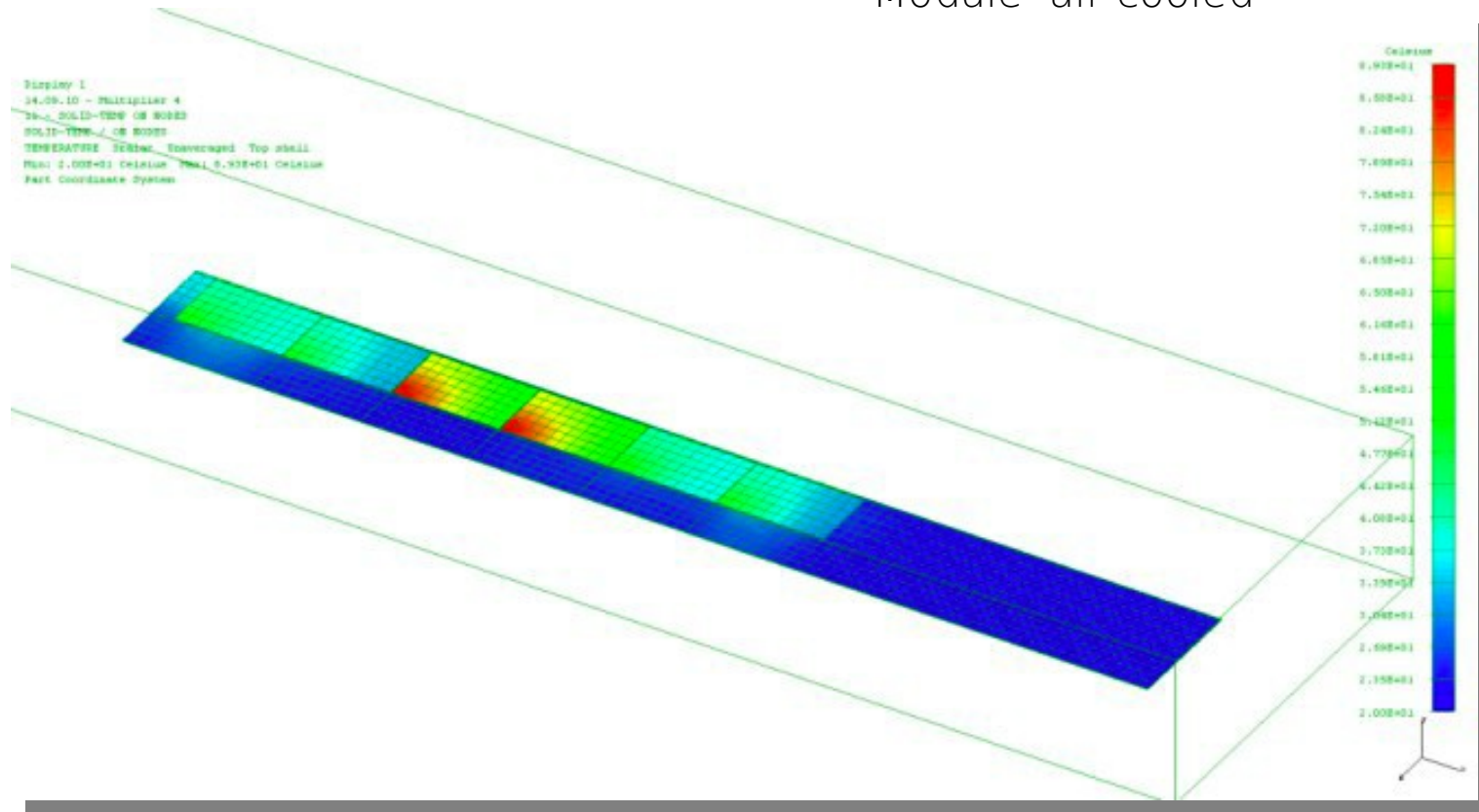


Module in the air cooling box



PLUME-2010 simulations

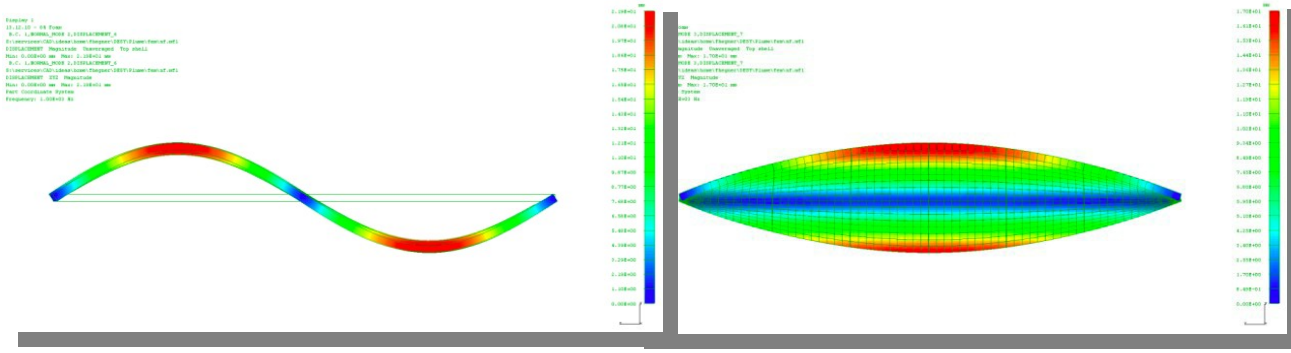
Module air cooled



→ importance of heat conductivity among sensors
for efficient cooling by air



Figure 1 shows a 3D plot of the deflection of a beam under a uniformly distributed load. The beam is represented by a curved line with a color gradient from blue (low deflection) to red (high deflection). The deflection is maximum at the center of the beam. The plot includes a coordinate system with X, Y, and Z axes. The Z-axis represents the deflection, with a scale from 0.000000 to 0.000000. The X-axis represents the length of the beam, with a scale from 0.000000 to 1.000000. The Y-axis represents the height of the beam, with a scale from 0.000000 to 0.000000. The plot is titled 'Zurück' and 'Zurück'.



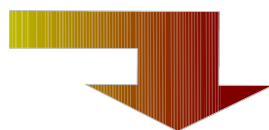
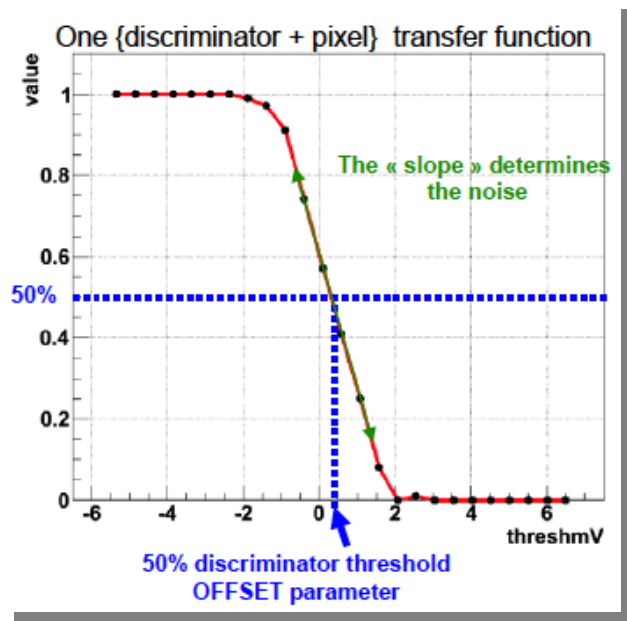
2C - Mode		SiC foam 8% in Hz	SiC foam 4% in Hz	RVC in Hz
One sensor/ Two sensors/ Three sensors	1	255	265	235
	2	990	981	453
	3	1281	1117	674

Ultra-light pixellated systems, 2011, Sept. 8



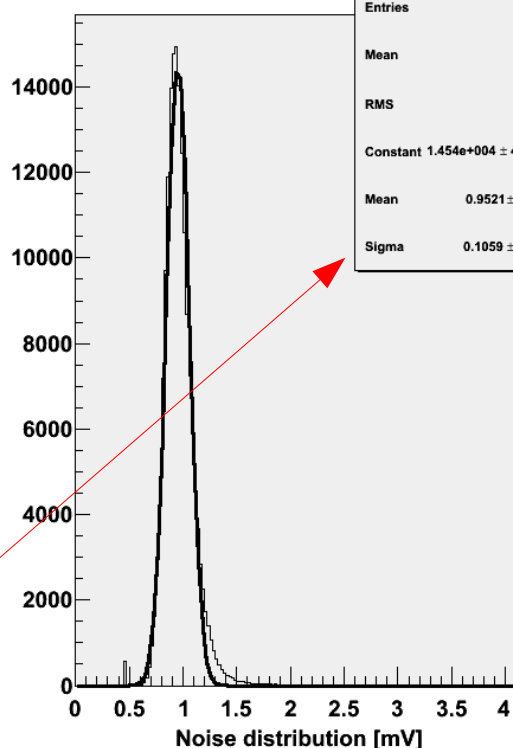
PLUME-2010 electrical tests

Scan of the discriminator thresholds with all 6 sensors switched on (5 tuned for 1% occupancy)

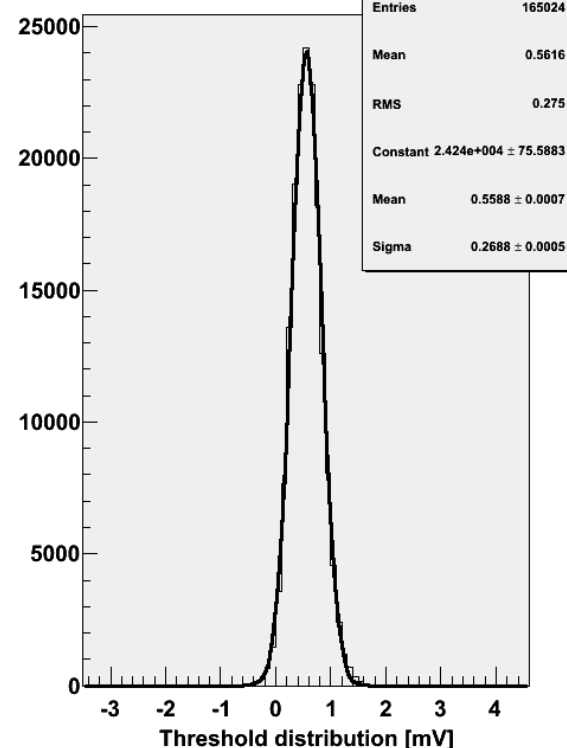


Current consumption/sensor ~ 230 mA
@ low threshold

Temporal noise



Fixed pattern noise



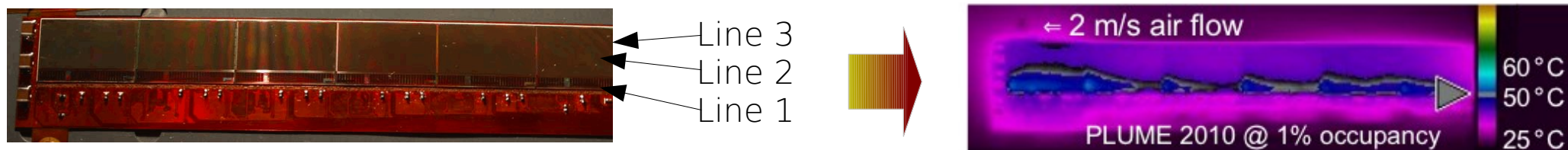
Temporal noise at mV level
as expected from single sensor
measurements

→ Waiting for quantitative measurement of fake hit rate with threshold
(very soon)

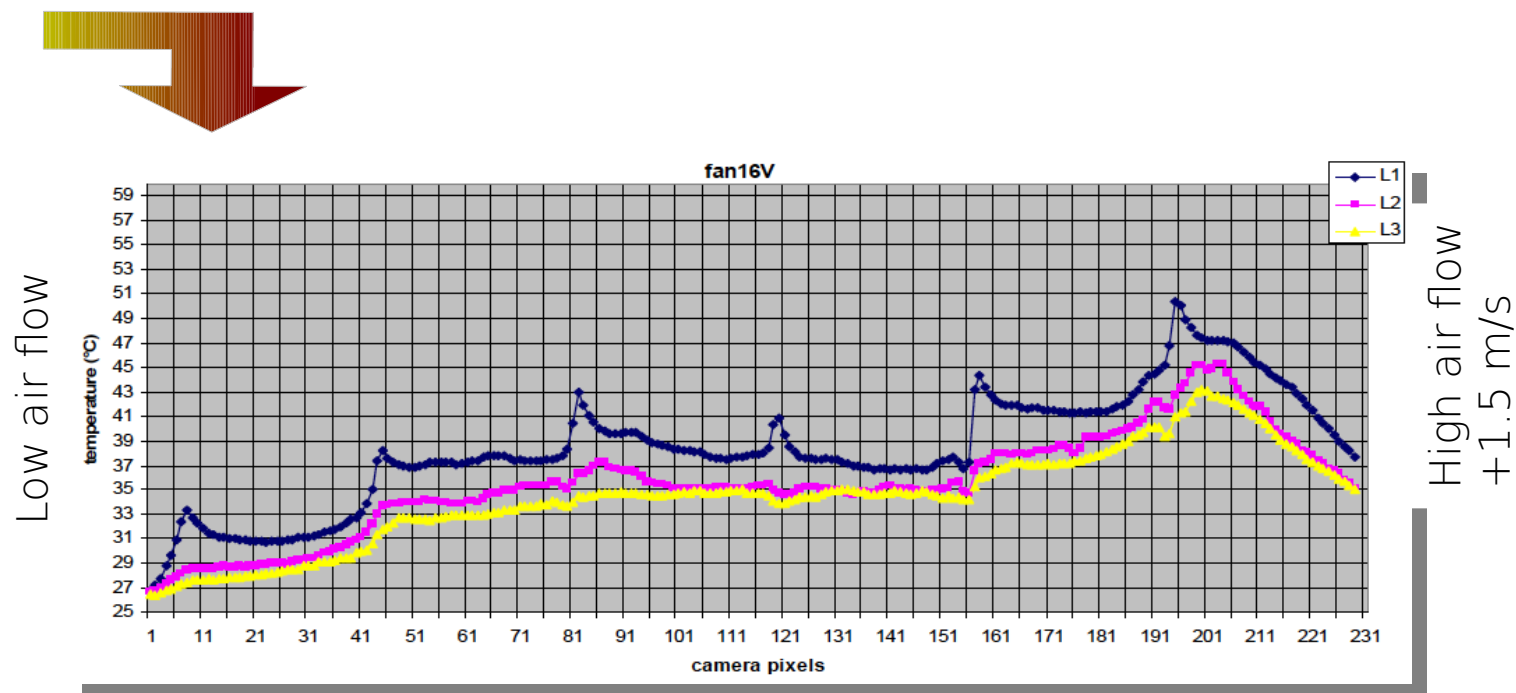
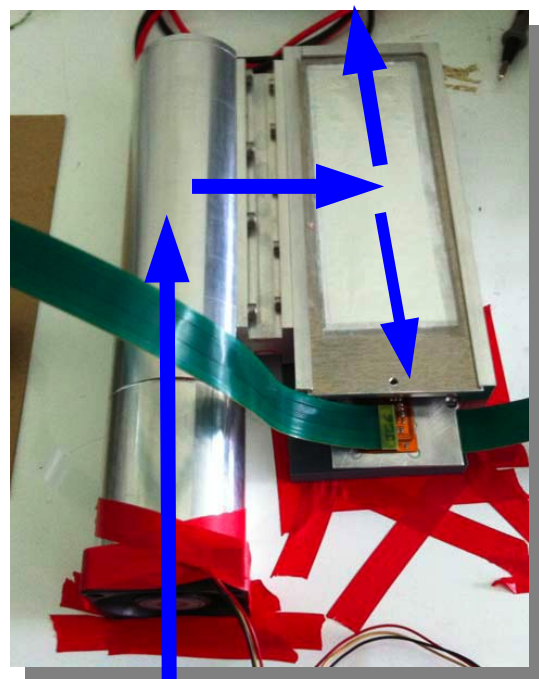


PLUME-2010 thermal tests

IR camera thermal measurement on a single module



MIMOSA 26 internal (diode) temp. measurement on ladder only 1 over the 2 modules switched on



ambient air

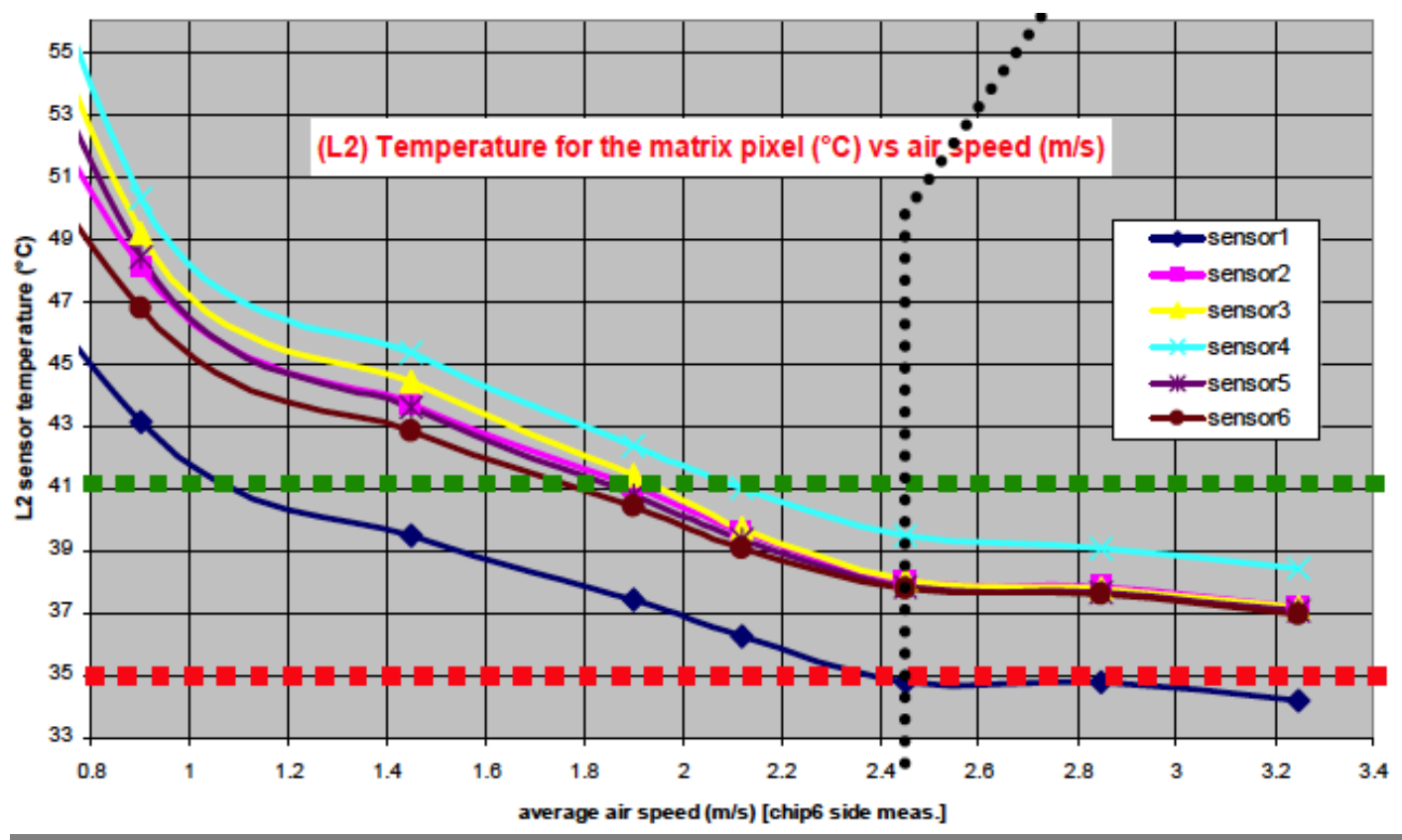


PLUME-2010 thermal tests

IR camera thermal measurement on a single module



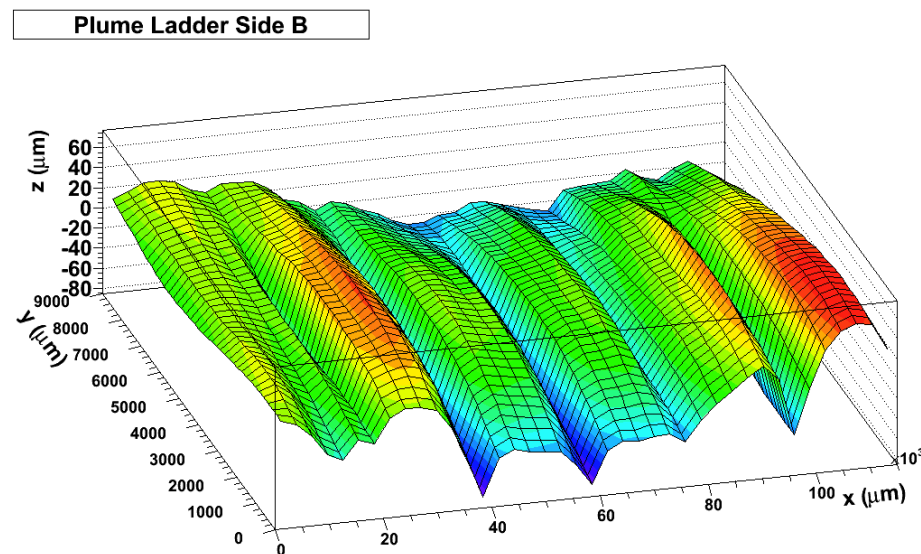
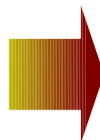
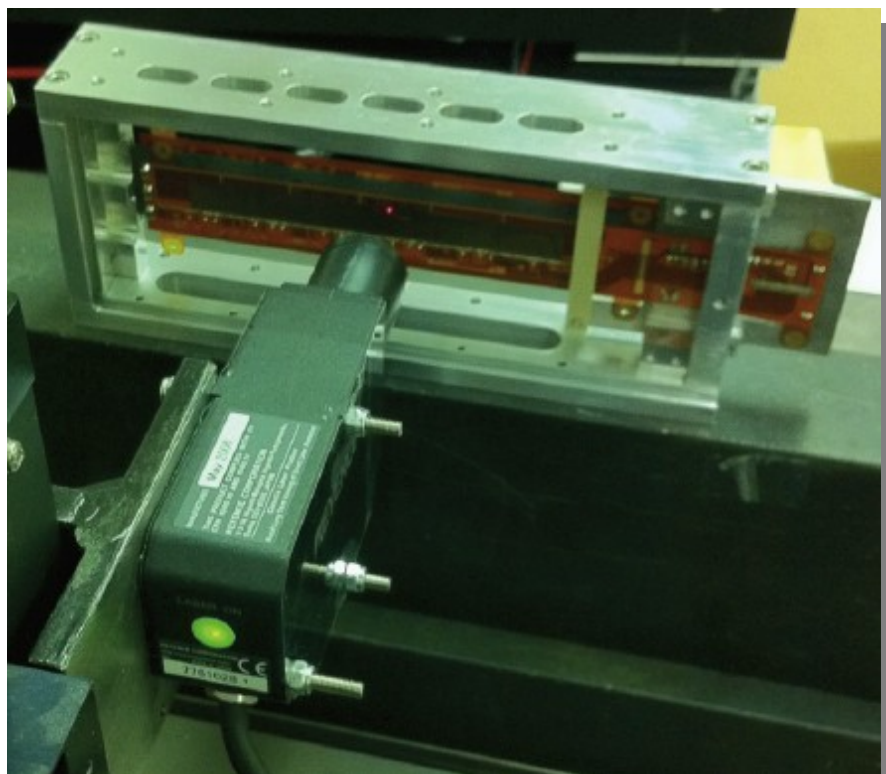
MIMOSA 26 internal (diode) temp. measurement on ladder only 1 over the 2 modules switched on





PLUME-2010 mechanical tests

Surface survey of ladder with dummy sensors



With the help of Ryan Page & setup from RAL

Functional ladder air cooled

→ Waiting for survey and vibration measurements for quantitative conclusion (end of September 2011)

→ Waiting for test beam at CERN-SPS with 120 GeV π (november 2011)



PLUME-2011 design

● Why is the 2010 design so thick ?

- x cable width $\sim 2 \times$ sensor width
- x metal \sim copper
- x SiC foam (spacer) density $\sim 8\%$



● New (2011) design

- x cable width \sim sensor width + 4 mm (wire bonds+SMD comp.)
- x metal \sim aluminum (CERN) (still copper from industry)
- x SiC foam (spacer) density $\sim 4\%$



● New (PRELIMINARY) material budget

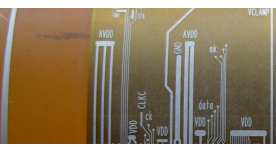
- x transverse cross-section
 - $0.344 \% X_0 = 2 \times 0.053(\text{sensors}) + 2 \times 0.058(\text{flex}) + 0.092(\text{SiC}4\%) + 0.030(\text{SMD})$
- x average (weighted / 10 mm wide MIMOSA 26 sensitive layer)
 - $0.502 \% X_0 = 2 \times 0.069 (\text{sensor}) + 2 \times 0.098 (\text{flex}) + 0.138 (\text{SiC}4\%) + 0.030 (\text{SMD})$



● Schedule

- x copper cable version in test
- x Aluminum cable version expected in Oct.
- x semi-automatic positioning machine for module assembly available in Nov.
- x First ladder in 2012-Q1
- x Ladder small prod. (~ 10) » mid-2012

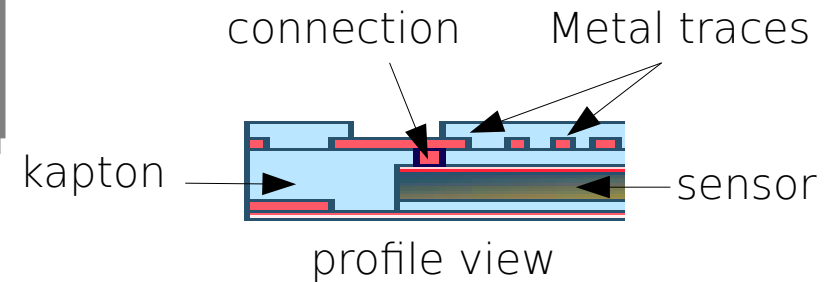
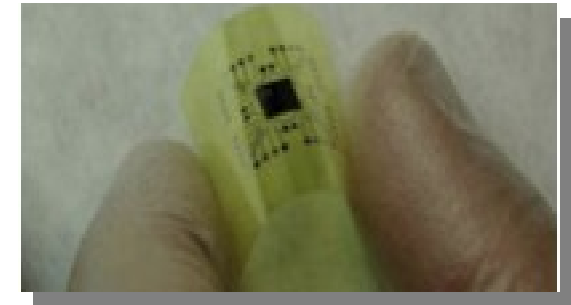
Sensor embedding



Rationale

- x Get rid of the wire bonds (less material)
- x Provide a mechanical protection to sensors
 - ➔ allows thinner sensors
 - ➔ Allows more mechanical stress by evening it
- x Possibilities
 - ➔ Lower material budget (average ~ cross section)
 - ➔ Supportless
 - ➔ cover non planar surface

SEnsor Row Wrapped In
Extra-Thin Envelope = SERWIETE



Difficulty

- x Alignment of the narrow pad rings of several sensors over a long distance (~ladder length)
- x Add metal layers over the embedded sensors

IMEC-CFRM process

- x SERWIETE

CERN process

- x CERNWIETE

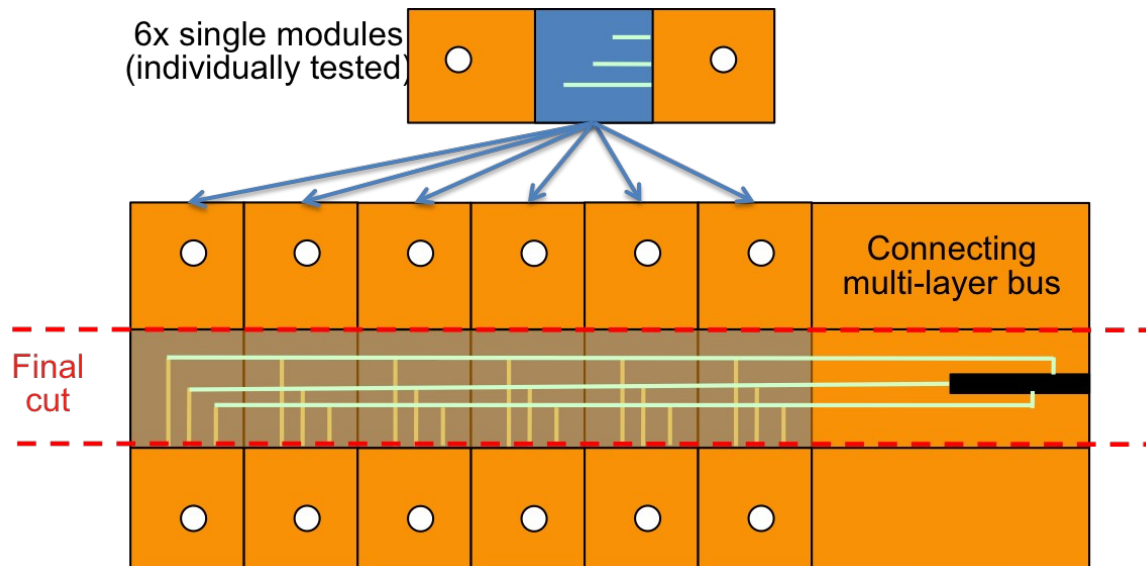
Sensor embedding: CERN

Idea from R. De Oliveira, W.Dulinski

- x Embed sensor one at time
 - Alleviate alignment difficulty
 - Allow individual testing before assembly (yield)
- x Processing of further metal layers decoupled from sensor embedding

Questions

- x Insensitive area in-between sensors?
 - Possibility to overlay embedded sensors



Gluing 1 sensor between two kapton foils

Opening vias using lithography

Al (5-10 μm) sputtering & lithography

Gluing another kapton foil for further processing

Material budget

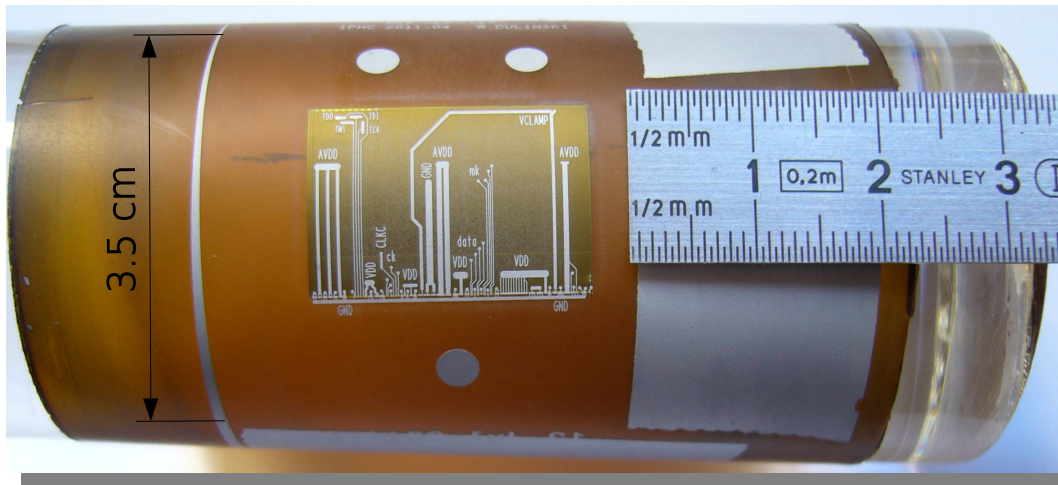
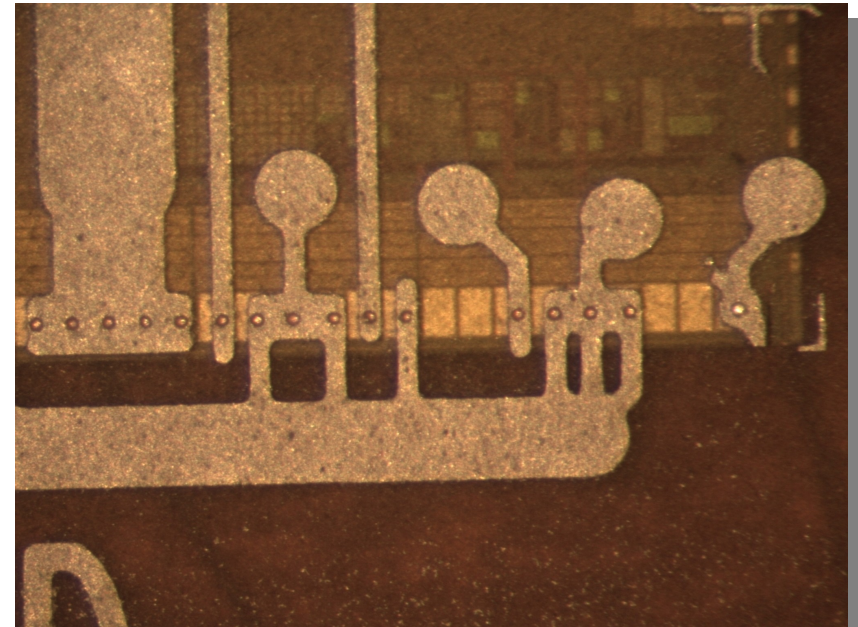
- x Embed sensor one at time
 - Alleviate alignment difficulty
 - Allow individual testing before assembly (yield)
- x Processing of further metal layers decoupled from sensor embedding

Sensor embedding: CERN

Status

- x First single sensor embedded,
- x Not functional because connection problem
 - Vias under microscope investigation
 - Used for stress test
- x Interconnecting bus design ready
 - 3 metal layers (guarantee impedance)
- x Further processing this Fall

Detail of vias on sensor pads



→ No cracks visible on the silicon,
still await electrical confirmation
→ Thermal behavior?

● PLUME

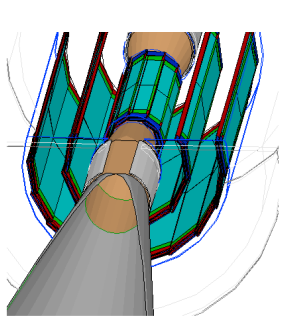
- x A first (functionally) successful design in 2010 to be fully validated in Nov. 2011
- x New design in 2011 to reach material budget of (cross sect.) $O(0.03) \% X_0$
- x Simulation effort to validate models to predict new designs performances
- x "infrastructures" in place for further designs and/or other sensors

● Sensor embedding (SERWIETE & CERNWIETE)

- x Quite promising, probably 1st manifestation of new integrations methods/technics within the reach of CMOS pixel sensors
- x Still expecting a first functional prototype (<2012 according to plan)

● Applications ?

- x PLUME beam tests will be an important milestones for the ILD available in 2012 (to be compared with DEPFET-based Belle II-VXD & STAR-PXL)
- x 6 to 8 ladders (12 x MIMOSA 26 each) will run during long beam periods in the framework of the FP7-AIDA project
 - ➔ Complementary experience wrt STAR-PXL



● Additional slides

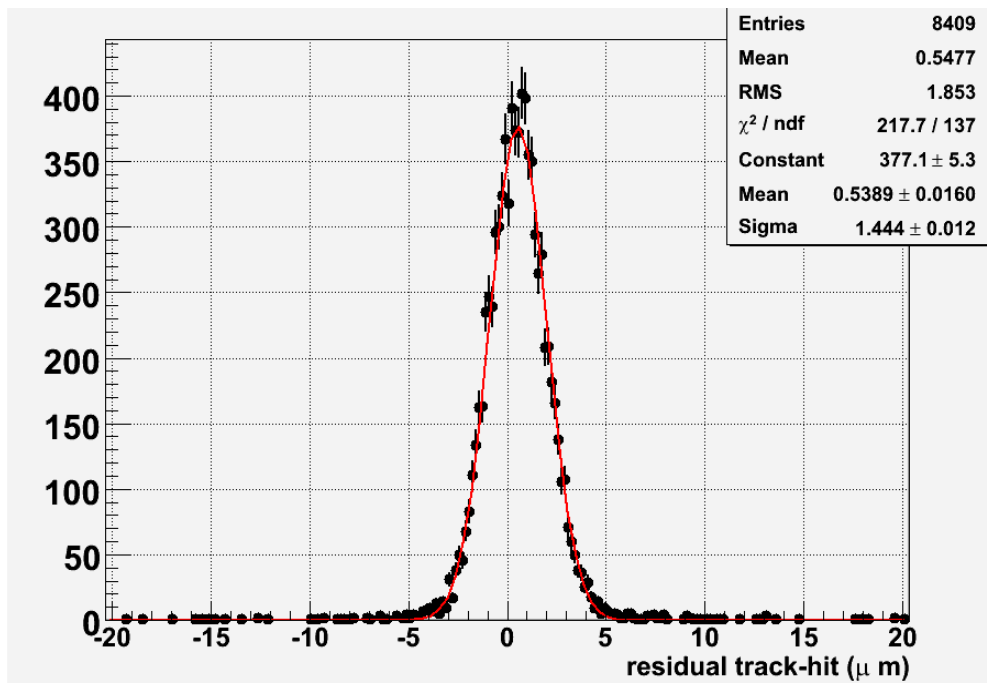
x



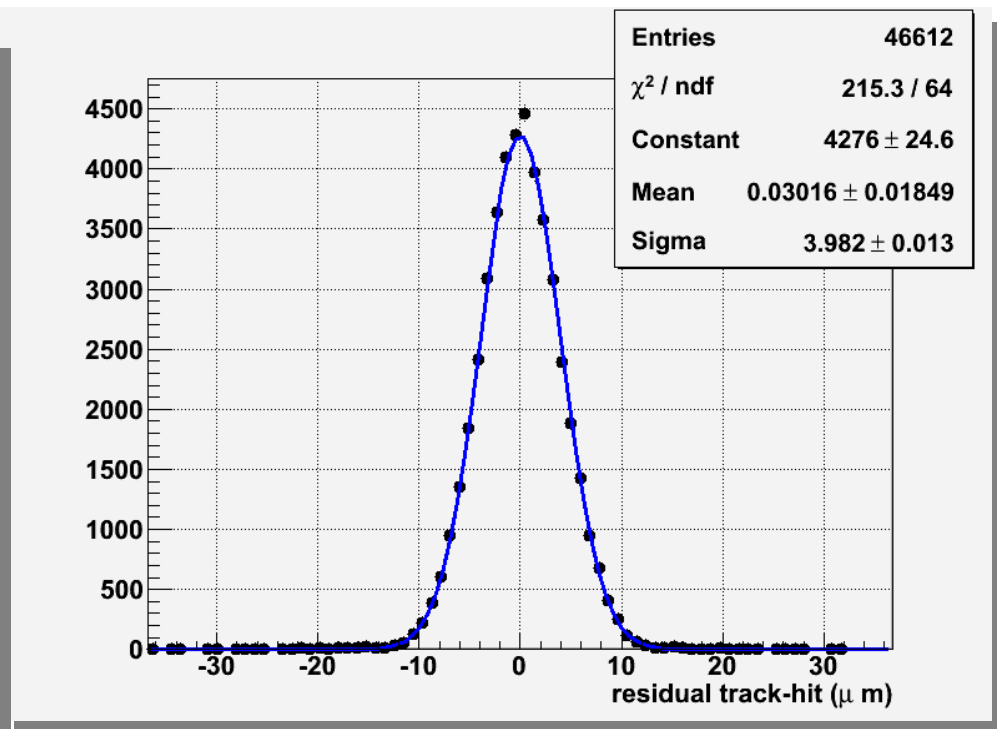
Defining the spatial resolution

From the residual resolution

- ✗ Fit with a single gaussian
- ✗ Spatial resolution = single gaussian std. deviation



Analog sensor case:
MIMOSA 18, pitch $10\ \mu\text{m}$

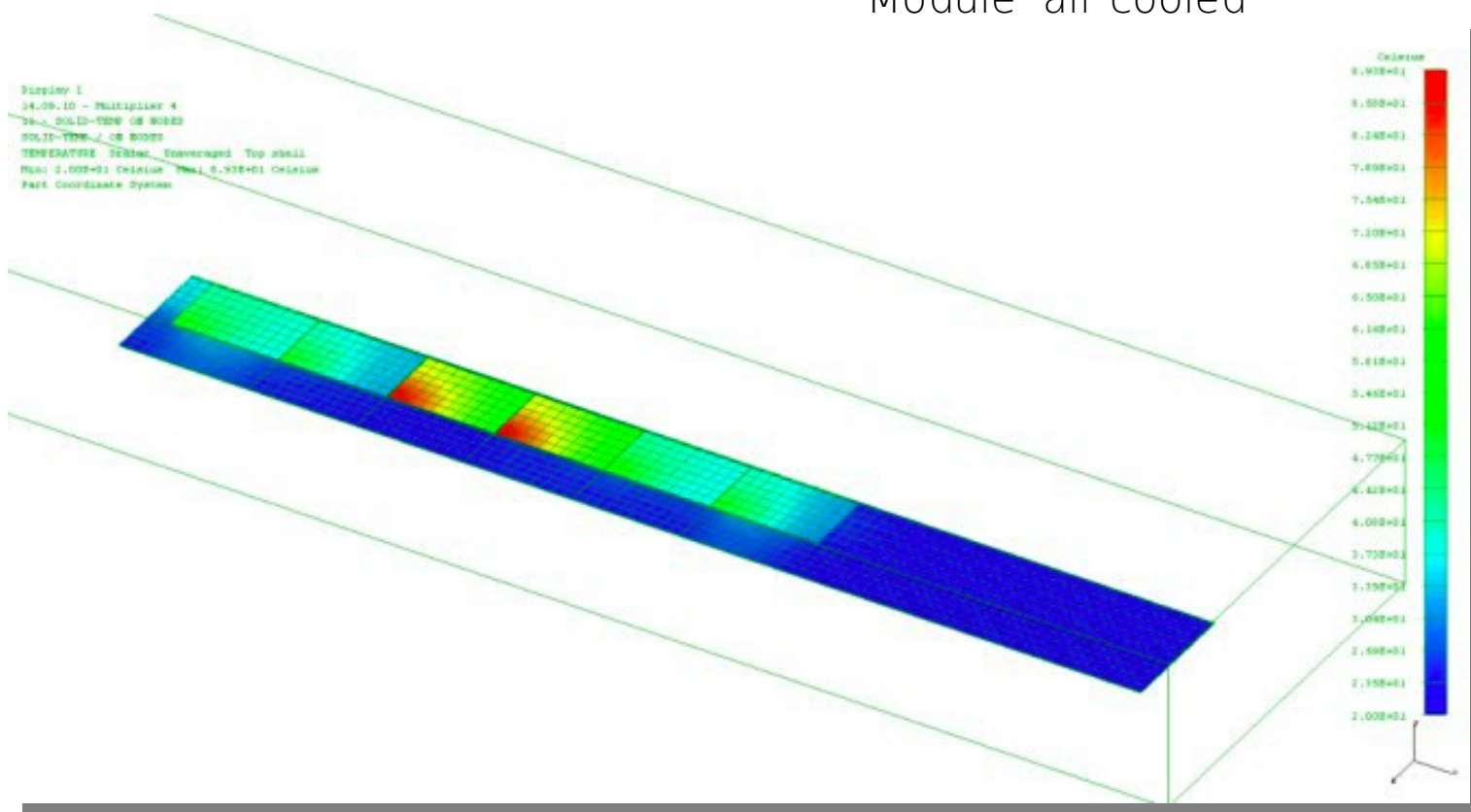


Binary sensor case:
MIMOSA 26, pitch $18.4\ \mu\text{m}$



PLUME-2010 simulations

Module air cooled

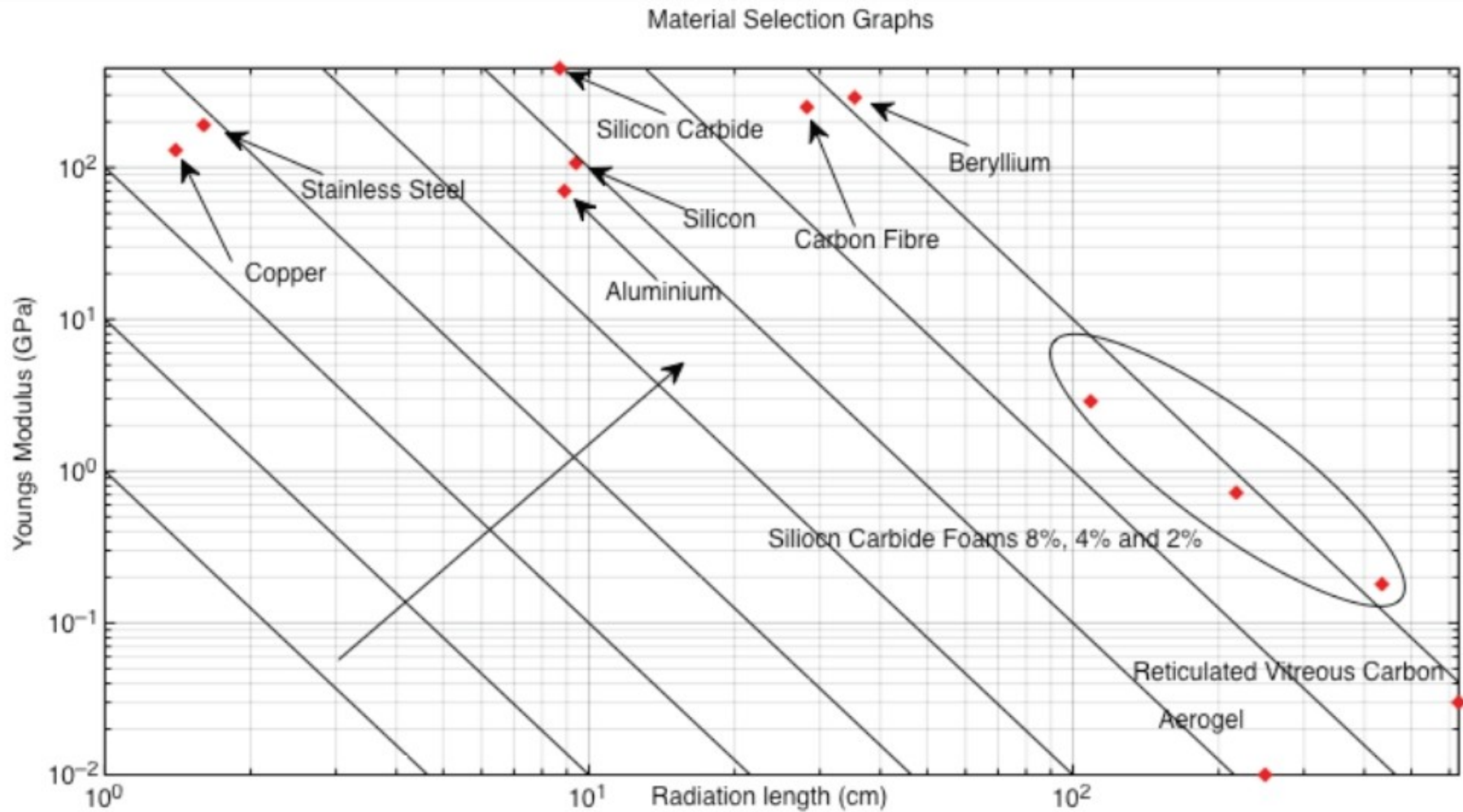




PLUME-2010 simulations

Module air cooled

Materials for stiffener/spacer



From Joel Goldstein, Bristol U.

Parameter space for a VXD

